

RECEIVED
CENTRAL FAX CENTER

002

AUG 10 2005

PATENT APPLICATION
Do. No. 4591-383
Client No. IE10112-US-1

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of: You-Cheol SHIN, et al.

Serial No.: 10/777,233 Examiner: Brewster, William M.
Filed: February 11, 2004 Group Art Unit: 2823
For: SEMICONDUCTOR DEVICE AND METHOD OF
MANUFACTURING THE SAME INCLUDING FORMING METAL
SILICIDE GATE LINES AND SOURCE LINES (as amended)

Mail Stop Issue Fee
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

AMENDMENT AFTER ALLOWANCE UNDER 37 CFR § 312

Responsive to the Notice of Allowance, dated May 11, 2005, please amend the application as follows.

OK to Enter

William M. Brewster

16 SEPS

Docket No. 4591-383
Amendment After Allowance

Page 1 of 5

Application No. 10/777,233
Client No. IE10112-US-1